

Electronic Patent Application Fee Transmittal

Application Number:	10706902			
Filing Date:	12-Nov-2003			
Title of Invention:	Selective etch process of a sacrificial light absorbing material (SLAM) over a dielectric material			
First Named Inventor:	Hee Yeop Chae			
Filer:	Alan Michael Taboada			
Attorney Docket Number:	AMAT/8501/ETCH/DRIE/JB			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Claims in excess of 20	1202	1	50	50
Independent claims in excess of 3	1201	1	200	200
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				250